

11-29-05

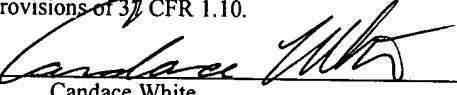
PATENT APPLICATION

cc) TDA
a.c.IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:) Docket No.: ATMI-668 (7493)
Applicants: RATH, Melissa K., et al.) Conf. No.: 4823
Application No.: 10/792,038) Art Unit: 1752
Date Filed: March 3, 2004) Examiner: LE, Hoa Van
Title: COMPOSITION AND) Customer No.: 25559
PROCESS FOR POST-ETCH)
REMOVAL OF)
PHOTORESIST AND/OR)
SACRIFICIAL ANTI-)
REFLECTIVE MATERIAL)
DEPOSITED ON A)
SUBSTRATE)

EXPRESS MAIL CERTIFICATE

I hereby certify that I am mailing the attached documents to the Commissioner for Patents on the date specified, in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 and Express Mailed under the provisions of 37 CFR 1.10.


Candace White

November 28, 2005

Date

EO 006 644 865 US

Express Mail Label Number

AMENDMENT RESPONDING TO OCTOBER 24, 2005 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/792,038

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the October 24, 2005 Office Action in the above-identified application.

11/30/2005 DEMMANU1 00000045 10792038

01 FC:1201
02 FC:1202200.00 OP
350.00 OP

Please add claims as set out in the following **Section I (the Claims)**.

Remarks addressing the substance of the October 24, 2005 Office Action are set out in the **Section II (Remarks)** hereof.